

501.43187X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Hiroyuki IKEDA, et al.  
Serial No.: Not yet assigned  
Filed: October 29, 2003  
For: A METHOD OF MANUFACTURING A SEMICONDUCTOR  
DEVICE AND A SEMICONDUCTOR DEVICE  
Group: Not yet assigned  
Examiner: Not yet assigned

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

October 29, 2003

Sir:

The following amendments and remarks are respectfully submitted in  
connection with the above-identified application:

**Amendments to the Claims**